

**QUALCOMM® QUICK CHARGE™ 3.0 TECHNOLOGY**  
**HIGH VOLTAGE DEDICATED CHARGING PORT**  
**VERIFICATION**

**ISSUED BY**  
**UL VERIFICATION SERVICES INC.**

<b>CERTIFICATE NO</b>	▶ 4788162444-2
<b>SPECIFICATION</b>	▶ Qualcomm HVDCP Interface Specification Revision K
<b>APPROVAL DATE</b>	▶ November 8, 2017
<b>APPROVAL TYPE</b>	▶ ORIGINAL ASSESSMENT
<b>CERTIFICATE HOLDER</b>	▶ Dialog Semiconductor ▶ 675 Campbell Technology Pkwy ▶ Campbell, CA 95008
<b>TYPE OF EQUIPMENT</b>	▶ Chipset Reference Design
<b>TRADE NAME AND MODEL</b>	▶ Dialog Semiconductor ▶ iW662
<b>MEASUREMENT FACILITIES</b>	
<b>LABORATORY NAME AND ADDRESS</b>	▶ UL Verification Services Inc. ▶ 47266 Benicia Street ▶ Fremont, CA 94538 ▶ USA

*Verification of equipment means only that the equipment has met the requirements of the above-noted specification. Trademark applications and agreements regarding the use of Quick Charge 3.0 Logo, are acted on accordingly by Qualcomm Technologies, Inc. This certificate is issued on condition that the holder complies and will continue to comply with the Quick Charge 3.0 program requirements established by Qualcomm Technologies, Inc. The equipment for which this certificate is issued shall not bear the Qualcomm Quick Charge 3.0 Logo unless the equipment complies with the applicable technical specifications and agreements issued by Qualcomm Technologies, Inc. as applicable to the Type Of Equipment designated above.*

*I hereby attest that the subject equipment was tested and found in compliance with the above-noted specification.*

**ISSUED BY:**



DANIEL CHIANG  
PROJECT ENGINEER, UL Taiwan Co., Ltd.

**ISSUED ON:** ▶ November 8, 2017

